

Thank you for downloading this document from the RMIT Research Repository.

The RMIT Research Repository is an open access database showcasing the research outputs of RMIT University researchers.

RMIT Research Repository: http://researchbank.rmit.edu.au/



PLEASE DO NOT REMOVE THIS PAGE

Characterization of metal contacts for two-dimensional MoS₂ nanoflakes

Sumeet Walia,^{1,2,a)} Sivacarendran Balendhran,^{1,2} Yichao Wang,² Rosmalini Ab Kadir,² Ahmad Sabirin Zoolfakar,² Paul Atkin,² Jian Zhen Ou,² Sharath Sriram,^{1,2} Kourosh Kalantarzadeh^{2,a)} and Madhu Bhaskaran^{1,2,a)}

¹ Functional Materials and Microsystems Research Group, RMIT University, Melbourne, Victoria 3000, Australia

² School of Electrical and Computer Engineering, RMIT University, Melbourne, Victoria 3000, Australia

ABSTRACT

While layered materials are increasingly investigated for their potential in nanoelectronics, their functionality and efficiency depend on charge injection into the materials *via* metallic contacts. This work explores the characteristics of different metals (aluminium, tungsten, gold and platinum) deposited on to nanostructured thin films made of two-dimensional (2D) MoS₂ flakes. Metals are chosen based on their work functions relative to the electron affinity of MoS₂. It is observed, and analytically verified, that lower work functions of the contact metals lead to smaller Schottky barrier heights and consequently higher charge carrier injection through the contacts.

KEYWORDS

Contacts, work function, electron affinity, nanoflakes, MoS₂

Two-dimensional (2D) materials are gaining significant attention due to their unique electrical, mechanical and optical properties, which are different than those of their bulk counterparts.^{1,2} In particular, 2D transition metal dichalcogenides are attracting extensive research interest due to possibilities of electronic band structure manipulations.^{1,2} Amongst them, molybdenum disulphide (MoS₂) which is a n-type semiconductor, has been the most popular material owing to its relatively small bandgap (1.2 eV for multi-layer and 1.8 eV for monolayer), modest electron mobilities and transition from indirect to direct bandgap when it is exfoliated to monolayer thickness.^{1,2} Amidst the three known polymorphs of MoS₂ (1T, 2H and 3R), 2H-MoS₂ is the naturally occurring and thermodynamically stable phase.^{1,2} Bulk 2H-MoS₂ is composed of atomically thin planes comprising of covalently bonded S–Mo–S structures across the planes and weak van der Waals forces between the planes.³ Such a crystal structure enables the realisation of atomically thin stable 2D sheets of MoS₂ *via* mechanical and liquid exfoliation techniques.^{1,2}

2D MoS₂ has been applied in the development of a variety of devices including field effect transistors, electrically driven optical devices and solar cells, as well as electrochemical devices.^{4,5,6} All these devices rely on electrical contacts for their operation. As such, understanding metal/2D MoS₂ interface is crucial in such devices and the nature of the metal/2D MoS₂ depends on the electronic band structures of both the metal and 2D MoS₂.

In this letter, we provide a thorough experimental analysis of metal/nanostructured thin films made of 2D MoS₂ nanoflakes contacts for selected metals. The choice of metal contacts is based on their work functions (Φ_M) relative to the electron affinity (χ) of MoS₂. Relatively low work function metals, aluminium (Al) and tungsten (W), are studied along with relatively high work function metals, gold (Au) and platinum (Pt), in order to provide a wide-ranging picture of the behaviour of the metal/2D MoS₂ contacts. In this study, a grinding-sonication liquid exfoliation technique, adapted from the work of Yao *et al.*,⁷ is employed as a high yield method for producing suspensions of 2D MoS₂ nanoflakes.⁸ Atomic force microscopy (AFM) was employed to assess the thickness of the MoS₂ nanoflakes. It can be seen from Fig. 1(a) that typical MoS₂ nanoflakes comprise of 6 to 8 fundamental layers (1 layer = 0.65 nm)⁴. Measurements using a large number of AFM images shows that the majority of MoS₂ nanoflakes exhibit thicknesses in the range of 2-7 monolayers.⁹ Dynamic light scattering (DLS) analysis was conducted to assess the average lateral dimensions of the exfoliated nanoflakes (Fig. 1(b)) to be approximately 100 nm. The nanoflake suspension was drop-casted onto electrically conductive fluorine-doped tin oxide (FTO) substrates and left to dry under ambient conditions, resulting in thin films of ~500 nm thickness.

Raman spectroscopy was carried out to further characterise the MoS₂ thin films and estimate the number of layers they are comprised of. Figure 2(a) shows the Raman spectra of the bulk and the nanostructured MoS₂ thin film. The two dominant modes $(E_{2g}^1 \text{ and } A_{1g})$ reflect the vibrations of the Mo–S bond along the horizontal and vertical planes, respectively.¹⁰ For the MoS₂ nanoflakes, the A_{1g} mode showed no significant shift, while the E_{2g}^1 mode was observed to have red shifted in comparison to their bulk counterpart. This indicates a dominant presence of few-layered (<7 layers) MoS₂ nanoflakes in the thin film,^{9,11} which is also in agreement to the AFM analysis presented earlier.

X-ray diffraction (XRD) was utilized to determine the crystallinity of the drop-casted 2D MoS₂ nanostructured thin films. It can be seen from Fig. 2(b) that the dominant peak reflecting the (002) plane (ICDD Card no: 77-1716) was observed at 14.4°. In contrast to the XRD pattern of the bulk MoS₂, the nanostructured MoS₂ thin film did not reveal the presence

of (100), (106), (006), (105) and (008) planes. This reflects the nature of the thin films which consist of 2D MoS₂ nanoflakes composed of mostly (002) planes.

High resolution transmission electron microscopy (HRTEM) was conducted in order to verify the crystal structure of the 2D MoS₂ nanoflakes. The HRTEM image of the edges of the nanoflakes (Fig. 2(c)) confirms the presence of 2D structures with only several fundamental layers. The inset of Fig. 2(c) shows that the parallel lattice fringes of the MoS₂ nanoflakes are 0.27 nm apart, which is in agreement with previously reported values for 2H- MoS_2 .¹

In order to investigate the properties of metals when contacted with nanostructured films made of 2D MoS₂ nanoflakes, four different metals of Al, W, Au and Pt with varying work functions were considered. Al ($\Phi_{Al} = 4.54 \text{ eV}$)¹² and W ($\Phi_W = 5.09 \text{ eV}$)¹² were chosen as the low work function metals, while Au ($\Phi_{Au} = 5.40 \text{ eV}$)¹² and Pt ($\Phi_{Pt} = 5.70 \text{ eV}$)¹² were chosen as the high work function metals, relative to the electron affinity of MoS₂ ($\chi = 4.0 \text{ eV}$).^{6,13} A band diagram illustration of all the aforementioned metals relative to MoS₂, prior to contact is shown in Fig. 3(a). Figure 3(b) shows the current-voltage (*I-V*) characteristics acquired for the different metal/MoS₂ contacts. It can be seen that Al/MoS₂ interface results in the highest current (~90 µA), while the Pt/MoS₂ interface shows the least current (~10 µA), under identical bias conditions.

When the metal and the MoS₂ are brought in a contact, the bands of MoS₂ bend such that the Fermi levels equilibrate. Figure 4(a) schematically illustrates the respective electronic band alignment of the metals for the case of $\Phi_M > \chi$ (in our case, the Φ_M of Al, W, Au and Pt all are larger than χ), before the metal and MoS₂ and brought into contact. On making contact, the conduction and valence bands of the MoS₂ bend in order to achieve equilibrium between the metal Fermi level and the MoS₂ chemical potential (4.36 eV).¹⁴ The degree and the direction of band bending depend on the work function of the metal relative to the Fermi level of the semiconductor (MoS₂ in this case). With MoS₂ as the n-type semiconductor and for the case where the metal work function is larger than the electron affinity of MoS₂, the depiction shown in Fig. 4(b) arises after the metal and semiconductor are brought into contact. In this case, the electrons diffuse from the semiconductor to the lower energy states of the metal in order to achieve a constant Fermi level throughout the system in thermal equilibrium. This results in the upward band bending within MoS₂ at the interface. Consequently, the electrons in the metal see a potential barrier against their migration into the semiconductor. This barrier is known as the Schottky barrier (Φ_B) which can be estimated by the Schottky-Mott rule ($\Phi_B = \Phi_M - \chi$), where χ is the electron affinity of the semiconductor). A higher Φ_M thus results in a higher Φ_B . Hence, a larger forward bias is required in order to overcome this Schottky barrier.

This is confirmed from the *I-V* characteristics (Fig. 3(b)), in which it is seen that the current is progressively higher for lower work function metals such as Al and W under identical bias conditions. Table I summarises the experimental results obtained using different metal contacts with varying work functions, relative to the electron affinity of MoS₂. This shows that Al (the lowest work function metal) results in the highest bias current, indicating its superior room temperature charge injection capabilities for an interface with MoS₂, compared to commonly used contact metals such as Au and Pt. The estimated Schottky barrier heights using the Schottky-Mott relationship are shown in Table I. We also calculated the Schottky barrier heights from the *IV* curves. The calculated Φ_B for Al (0.55 eV) corresponds well to the theoretically estimated value. However, an accurate calculation for the other metals could not be obtained, as their relatively large Φ_B required the application of higher bias voltages, causing the junction to break down.

In summary, we investigated the properties of the metal/2D MoS₂ contacts using metals of different work functions and demonstrated that for the chosen metals that have the work functions between 4.5 to 5.7 eV, always Schottky behaviours were observed. While, there are reports in literature that have claimed the Au/2D MoS₂ contact to be Ohmic, our study clearly shows the formation of a barrier height and therefore Schottky behaviour for all of the metals under investigation. This study showed that the choice of the metal contacts is crucial in adjusting the barrier heights at their interface with 2D MoS₂, which is fundamental knowledge in designing electronic and optoelectronic devices based on 2D MoS₂.

ACKNOWLEDGMENTS

The authors acknowledge support from the Australian Research Council (ARC) with partial project support through Discovery Project DP130100062; Australian Post-Doctoral Fellowships through Discovery Projects DP1092717 (MB) and DP110100262 (SS); and equipment funding through the Linkage, Infrastructure, Equipment, and Facilities Grant LE100100215 (SS and KKZ). SB acknowledges a publication grant from the School of Graduate Research at RMIT University.

NOTES

^{a)}Corresponding authors. E-mail: <u>madhu.bhaskaran@rmit.edu.au</u>, <u>kourosh.kalantar@rmit.edu.au</u> and <u>sumeet.walia@rmit.edu.au</u>

REFERENCES

- S. Balendhran, S. Walia, H. Nili, J. Z. Ou, S. Zhuiykov, R. B. Kaner, S. Sriram, M. Bhaskaran, and K. Kalantar-zadeh, Adv. Funct. Mater. 23, 3952 (2013).
- Q. H. Wang, K. Kalantar-Zadeh, A. Kis, J. N. Coleman, and M. S. Strano, Nat. Nanotechnol.
 7, 699 (2012).
- 3. D. J Late, B. Liu, H.S.S. Ramakrishna Matte, V. P. Dravid, and CNR Rao, ACS Nano 6, 5635 (2012).
- 4. B. Radisavljevic, A. Radenovic, J. Brivio, V. Giacometti, and A Kis, Nat. Nanotechnol. **6**, 147 (2011).
- H. Wang, L. Yu, Y-H. Lee, Y. Shi, A. Hsu, M. L. Chin, L-J. Li, M. Dubey, J.Kong, and T. Palacios, Nano Lett. 12, 4674 (2012); Z. Yin, H. Li, H. Li, L. Jiang, Y. Shi, Y. Sun, G. Lu, Q. Zhang, X. Chen, and H. Zhang, ACS Nano 6, 74 (2011); G. Eda, H. Yamaguchi, D. Voiry, T. Fujita, M. Chen, and M. Chhowalla, Nano Lett. 11, 5111 (2011).
- 6. S. Das, H-Y. Chen, A. V. Penumatcha, and J. Appenzeller, Nano Lett. 13, 100 (2012).
- Y. Yao, L. Tolentino, Z. Yang, X. Song, W. Zhang, Y. Chen, and C-P. Wong, Adv. Funct. Mater. 23, 3577 (2013).
- 8. See supplementary material at [URL to be inserted by AIP] for experimental details outlining the materials and methods used in this work.
- Y. Wang, J. Z. Ou, S. Balendhran, A. F. Chrimes, M. Mortazavi, D. D. Yao, M. R. Field, K. Latham, V. Bansal, J. R. Friend, S. Zhuiykov, N.V. Medhekar, M. S. Strano, and K. Kalantar-zadeh, ACS Nano, DOI: 10.1021/nn4041987 (2013).
- S. Balendhran, J. Z. Ou, M. Bhaskaran, S. Sriram, S. Ippolito, Z. Vasic, E. Kats, S. Bhargava,
 S. Zhuiykov, and K. Kalantar-Zadeh, Nanoscale 4, 461 (2012).
- D. J. Late, B. Liu, H. S. S. Ramakrishna Matte, C. N. R. Rao, and V. P. Dravid, Adv. Funct. Mater. 22, 1894 (2012).
- 12. H. Lomholt Skriver and N. M. Rosengaard, Phys. Rev. B. 46, 7157 (1992).

- K. Lee, H-Y. Kim, M. Lotya, J. N. Coleman, G-T. Kim, and G. S. Duesberg, Adv. Mater. 23, 4178 (2011).
- J-M. Yun, Y-J. Noh, J-S. Yeo, Y-J. Go, S-In Na, H-G. Jeong, J. Kim, S. Lee, S-S. Kim, and H. Y. Koo, J. Mater. Chem. C. 1, 3777 (2013).

| Metal | Work function, $\Phi_{\rm M} (eV)$ | Schottky barrier height, $\Phi_B = \Phi_M - \chi (eV)$ | Current at +2V bias (µA) |
|-------|-------------------------------------|---|-----------------------------|
| Al | 4.5 | 0.5 | 91.9 |
| W | 5.1 | 1.1 | 38.7 |
| Au | 5.4 | 1.4 | 22.5 |
| Pt | 5.7 | 1.7 | 17.3 |

TABLE I: Performance summary of different metal/2D MoS₂ contacts

FIGURE CAPTIONS

FIG. 1. (a) AFM image of typical exfoliated MoS_2 nanoflakes with its corresponding crosssectional thickness profile. (b) DLS analysis of the lateral size distribution of the MoS_2 nanoflakes.

FIG. 2. (a) Raman spectra comparison of bulk MoS_2 and a nanostructured 2D MoS_2 thin film. (b) X-ray diffractograms comparing bulk MoS_2 powder, a nanostructured thin film made of 2D MoS_2 nanoflakes, with the FTO substrate spectrum provided for reference (* denotes the peaks corresponding to the FTO substrate). (c) Transmission electron micrograph of a liquid exfoliated 2D MoS_2 nanoflake with the inset corresponding to its high resolution transmission electron micrograph.

FIG. 3. (a) Band diagram illustrations of a metal and MoS₂. χ is the MoS₂ electron affinity, E_F is the Fermi level of MoS₂, E_{VAC} is the reference vacuum level, E_V and E_C are the valence and

the conduction band levels respectively. (b) I-V characteristics for different metal/MoS₂ contacts under identical bias conditions.

FIG. 4. Band alignments of a metal and MoS_2 for $\Phi_M > \chi$ (a) before establishing a contact and (b) their corresponding band bending after establishing a contact.







